



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9620**
Masanobu NOGOME et al. : Docket No. 2003_1075A
Serial No. 10/630,900 : Group Art Unit 2818
Filed July 31, 2003 : Examiner Mai Huong Tran

SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action dated June 13, 2005, please amend the above-identified application as follows.